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Ali Cherry, Joël Abadie, Emmanuel Piat

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Modelling and optimization of a floating triangular platform used for nano and microforces sensing

A. Cherry, J. Abadie and E. Piat

Abstract—This paper presents the dynamic behaviour modelling of a horizontal triangular platform, used as the sensing part of a microforce sensor. This sensor is based on a magnetic and a buoyancy principle. A particular configuration used to obtain a linear model is presented. This linear model will be essential for the future control of the system, in order to achieve force measurement without displacement of the platform. The determination of the platform position and orientation in the horizontal plane is done thanks to three laser range sensors. The sensors configuration provide a linear transformation between the three measured ranges and the position and orientation of the platform. Finally, an open loop result comparison is done between the linear state model and a more complex 3D non-linear model.

I. INTRODUCTION

Manipulation with force control is an emerging area that appears certain to become an important component in microsystems technology. Pure position control is sometimes not suitable to ensure successful operation and prevent damage to the manipulated micro objects. Force control is often needed in order to achieve better manipulation results [6]. Moreover, in some specific applications like biological cells characterization, obtaining force information is a main objective [7] [8].

This paper presents the 2D modelling of a floating triangular platform which is the sensing part of a new magnetic nano and microforce sensor for a large field of applications (force identification, stiffness characterization, micro-assembly with force control,…). The platform on which the object to be handled or characterized is locked, presents a naturally stable six degrees of freedom equilibrium position using the combination of upthrust buoyancy and magnetic forces. The magnetic stiffness is typically between $10 \, nN/\mu m$ and $50 \, nN/\mu m$.

This paper presents the differential equations which govern the platform. In order to simplify these equations and to obtain a 2D linear model, a particular configuration of the magnetic and sensing parts have been studied. The 2D model is essential for the control of the system in order to achieve forces measurement without displacement of the platform. In this paper a way to calculate the platform position using the combination of three laser range sensors is also presented.

II. FORCE MEASUREMENT PRINCIPLE

Forces sensing is strongly related to the measurement of a rigid microstructure displacement or the deformation of an elastic structure [1]. The applied force is directly calculated using the structure stiffness which is established after calibration. Generally, calibration is a problem for micro and nano force sensors because of the lack of standard at this scale. Thus, calibration must be performed using indirect approaches.

The dry friction is the major problem for this measurement approach. Generally, micro and nano force sensors use elastic micro structures like micro beam to avoid dry friction [6]. Another way to avoid friction problem, is the use of levitation methods. In this case the absence of friction associated with a low stiffness makes the sensor highly sensitive. The only problem is that passive levitation is unstable. This result was shown theoretically for electrostatic case by Earnshaw in 1841 [5]. Attractive forces like magnetic forces coupled with repulsive forces like diamagnetic forces are needed to achieve passive levitation. A passive micro and nano force sensor using magnetic and diamagnetic forces was presented in [3].

In the new sensor presented here a special attention has also been devoted to the magnetic levitation approach. We decided also to use a floating principle rather than diamagnetic forces in order to stabilize the passive magnetic levitation. This principle allows to suppress the weight limitation of the levitating part (see figure 1).

With such a configuration, magnetic forces of the external magnets $p$ provide stability in the plane $(xOy)$ of the floating part inside which a small magnet $M$ is fixed. The upthrust buoyancy acting against the gravity provides stability along $z$ axis. In the plane $(xOy)$ the upthrust buoyancy has no action. Thus, the external forces in the plane $(xOy)$ applied to the floating part can be deduced according to the floating part magnetic stiffness and the displacement measured by a
This principle of force measurement related to the sensing part displacement of the microforce sensor can generate drawbacks in the case of high precision tasks such as biological cells micromanipulation or micro-assembling, where the manipulated object should not move. Thus, the key idea here is to develop a device which allows force measurements without any (or only very small) displacements of the sensitive part, thanks to an active control. The design used to make possible the feedback control loop is composed of two coils placed on both sides, above and below the floating magnet (see figure 2).

In case of an external force applied to the sensing element which tends to move it, the activation of coils will produce an opposed electromagnetic force \( \vec{F}_{\text{elec}} \) that will maintain the sensing element on its initial position. In this case, the current \( I \) in the coils is the new physical value related to the external force. The complete study of this force measurement principle and experimental validation are presented in [4].

III. STABILITY IN THE PLANE (xOy)

In this section, the study will be focused on the stability in the plane (xOy). The configuration considered is described in figure 2. We are not going to demonstrate mathematically this stability, but we will illustrate it with a simulation. The figure 3 shows the force \( \vec{F} \) vectors applied on the float, which is the sum of the magnetic force \( \vec{F}_{\text{mag}} \) generated by the two fixed cubic magnets \( p \) (represented by a square) and the electromagnetic force \( \vec{F}_{\text{elec}} \) generated by the two coils \( b \) (represented by a dotted circle). We can see clearly, when no current is applied in the coils \( (i = 0) \), the stable equilibrium position \( S \) of the moving cylindrical magnet \( M \) at \( x = 0.0115 \), \( y = 0 \) and \( z = 0 \). At this point, the magnetic force generated by \( p \) is null. A current \( i \) different from zero doesn’t disturb the stability in the plane but changes the position of \( S \) (see figure 3). \( S_i \) is the new stable equilibrium position for a non null current \( i \).

It remains to note that in case of small displacements around the point of equilibrium \( S \), the magnetic force \( \vec{F}_{\text{mag}} \) is quasi linear [2] and we can write:

\[
\vec{F}_{\text{mag}} / R = K_{\text{mag}} \cdot \vec{M} / R = \begin{bmatrix} K_{m_x} & 0 \\ 0 & K_{m_y} \end{bmatrix} \cdot \vec{M} / R \quad (1)
\]

where \( R \) is the reference frame of \((S,\vec{x},\vec{y})\) shown in figure 1 and \( M^T = [x_M, y_M] \) the position of the moving cylindrical magnet \( M \) in the plane \((xOy)\).

Around \( S \), the electromagnetic force is proportionnal to the current \( I \) in the coils [4] and we can write :

\[
\vec{F}_{\text{elec}} / R = K_{\text{elec}} \cdot i = \begin{bmatrix} K_e \\ 0 \end{bmatrix} \cdot i \quad (2)
\]

IV. 2D PLATFORM

In the following, the floating-magnetic principle described in section (II) will be used in order to construct a force
measurement device which will have, as a sensing element, a floating platform on which the object to be manipulated is locked (see figure 4). The platform mass is suspended against gravity by the combined upthrust buoyancy of three floats placed at the corners of the platform. Thus, the platform weight is not an issue for this sensor. Each degree of freedom in the plane \((xOy)\) can constitute a direction of force or couple measurement.

frames \(R_0\) and \(R_p\) are superimposed. \(M\) and \(S\) are also superimposed.

B. Change of reference frame

The reference frame change for a point \(M\) belonging to the platform, in the general case, is done by the following transformation:

\[
M_{/R_1} = P_{01}[(P_{0p} \cdot M_{/R_p}) + R_p - R_1]
\]  

(3)

\(P_{01}\) et \(P_{0p}\) are the crossing matrices from \(R_1\) to \(R_0\) and from \(R_p\) to \(R_0\) and they have the following expressions:

\[
P_{01} = [P_{01}]^{-1} = \begin{bmatrix} \cos \alpha & \sin \alpha \\ -\sin \alpha & \cos \alpha \end{bmatrix}, \quad P_{0p} = \begin{bmatrix} \cos \psi & \sin \psi & \cdot cos \psi \\ -\sin \psi & \cos \psi & \cdot sin \psi \end{bmatrix}
\]

in which \(\alpha\) is the angle formed by the two reference axes \(x_1\) and \(x_0\) and \(\psi\) is the angle formed by the two reference axes \(x_p\) and \(x_0\).

The reference frame change for a force vector \(\vec{F}\), under the same conditions, is done by the following transformation:

\[
F_{/R_0}^\tau = P_{01} \cdot F_{/R_1}^\tau
\]

(4)

C. Force \(\vec{F}\) applied on \(M\)

In this section, we give the expression of the force \(\vec{F}\) applied on \(M\) in \(R_0\). This force is the sum of the magnetic force \(F_{mag}\) due to \(p\) and the electromagnetic force \(F_{elec}\) due to the coil \(b\) applied to the moving cylindrical magnet \(M\) placed at the corner of the platform. For small displacements around \(S_1\), we have:

1) Magnetic force: According to equations (1), (3) and (4):

\[
F_{/R_0}^\tau = P_{01} \cdot K_{mag} \cdot P_{10}[(P_{0p} \cdot M_{/R_p}) + R_p - R_1]
\]

(5)

thus:

\[
F_{mag}^{/R_0} = (\sin \alpha \cdot K_{/M_x} \cdot \cos \alpha \cdot \sin \alpha \cdot X + \sin \alpha \cdot \sin \alpha \cdot Y) - (\cos \alpha \cdot \sin \alpha \cdot X - \sin \alpha \cdot \sin \alpha \cdot Y) + (\sin \alpha \cdot \sin \alpha \cdot X + \sin \alpha \cdot \sin \alpha \cdot Y) + (\cos \alpha \cdot \sin \alpha \cdot X - \sin \alpha \cdot \sin \alpha \cdot Y)
\]

with:

\[
S_{/R_0} = M_{/R_p} = \begin{bmatrix} X \\ Y \end{bmatrix}
\]
2) Electromagnetic force: According to equations (2), (3) and (4):

\[
F_{elec}^{\text{elec}} = P_{01} \cdot K_{elec} \cdot i_1
\]  

We can see easily that the expression of \(\vec{F}\) is not linear. So the idea was to use a particular configuration of the platform in order to simplify the differential equations which govern its movement.

D. Platform particular configuration

The figure 6 represents the selected configuration for the platform with 3 pairs of coils \(b_1\), 2 pairs of fixed cubic magnets \(p_1\) (5x5x5mm) and 2 cylindrical moving magnets \(M_1\) and \(M_2\) placed at the corners of the triangular platform, inside a float. An empty float is placed at the third corner in order to ensure the stability of the triangular platform along \(\vec{z}\) axis.

This configuration was retained in order to simplify to the maximum the differential equations which govern the movement of the platform and to limitate the coupling between the various directions of measurement (see section V). To each coil \(b_1\) a reference frame \(R_{b_1}\) is associated. To each pair of fixed cubic magnet a reference frame \(R_{p_1}\) is associated. The stable equilibrium position \(S_1\) of \(p_1\) is the origin of the reference frame \(R_{p_1}\) and the stable equilibrium position \(S_2\) of \(p_2\) is the origin of the reference frame \(R_{p_2}\), with:

\[
\begin{align*}
S_1/n_0 &= M_1/r_p = \begin{bmatrix} \delta & 0 \\ 0 & \delta \end{bmatrix} \quad \text{and} \quad S_2/n_0 &= M_2/r_p = \begin{bmatrix} -\delta & 0 \\ 0 & \delta \end{bmatrix}
\end{align*}
\]

V. PLATFORM POSITION

The determination of the external force \(F^{ext}\) in the plane \((xOy)\) is conditioned by the determination of the magnetic forces \(F_{p_1}^{mag}\) and \(F_{p_2}^{mag}\) applied on \(M_1\) and \(M_2\) (\(F_{b_1}^{elec}\), \(F_{b_2}^{elec}\) and \(F_{p_1}^{elec}\) are known thanks to the currents \(i_1\), \(i_2\) and \(i_3\) in the coils \(b_1\), \(b_2\) and \(b_3\)). The determination of these magnetic forces is possible knowing the position of the platform.

In this section we present the way to calculate the platform position \((X, Y, \psi)\) using three laser range sensors. An elementary configuration with only one laser sensor, used to measure the distance of a deflector fixed on the platform (on \(M\)), is first presented (see figure 7). The distance measured by the laser is given by the following expression:

\[
l = \frac{n_1/n_0 \cdot P \cdot M/n_0}{n_1/n_0 \cdot d/n_0}
\]

with:

\[
P : \text{origin of measurement}
\]
\[
\vec{d} : \text{laser direction}
\]
\[
I : \text{laser beam target on the deflector}
\]
\[
\vec{n} : \text{normal to the deflector surface}
\]
\[
l : \text{distance between } P \text{ and } I
\]

thus:

\[
l = \frac{(P_{01} \cdot n_1) \cdot (P_{01} \cdot M + R_p - P)}{(P_{01} \cdot n_1) \cdot \vec{d} \cdot \vec{n}}
\]

(7)

where:

\[
P_{01} = \begin{bmatrix} \cos \psi & \sin \psi \\ -\sin \psi & \cos \psi \end{bmatrix}, R_p = \begin{bmatrix} X \\ Y \end{bmatrix}/n_0, \vec{d} = \begin{bmatrix} x_d \\ y_d \end{bmatrix}/n_0
\]

\[
P = \begin{bmatrix} x_p \\ y_p \end{bmatrix}/n_0, \vec{n} = \begin{bmatrix} x_n \\ y_n \end{bmatrix}/n_p, A = \begin{bmatrix} x_A \\ y_A \end{bmatrix}/n_p
\]

The development of the equation (7) allows us to write:

\[
l = \frac{\cos \psi y_n - x_n \sin \psi y_d + x_d (x_n \sin \psi + y_n \cos \psi)}{(x_d x_n - x_n x_d) \sin \psi + (x_d y_n + y_n y_d) \cos \psi}
\]

\[
+ \frac{\sin \psi (x_n y_d - y_n x_d) \cos \psi + \psi (x_d y_n + y_n y_d) \cos \psi}{(x_d x_n - x_n x_d) \sin \psi + (x_d y_n + y_n y_d) \cos \psi}
\]

(8)

With 3 laser sensors, the determination of the platform position \((X, Y, \psi)\) is possible only if the 3 corresponding equations (8) are invertible.

Because (8) is not linear, an idea to determine \((X, Y, \psi)\) is to use a particular configuration which makes (8) linear.

A. Particular configuration

The selected configuration is as follows (see figure 8): \(\vec{d}\) and \(\vec{n}\) are colinear with a norm equal to one and \(\vec{n}\) is perpendicular to \(\vec{P}\) and \(\vec{A}\). Thus:

Fig. 6. Platform particular configuration

Fig. 7. Elementary configuration of laser sensor (top view)
\[
l = (x_n - y_n \tan \psi)X + (x_n \tan \psi + y_n)Y
+ (y_n x_p - x_n y_p) \tan \psi
\]
The laser range sensors are placed on \( P_1, P_2 \) and \( P_3 \) with:
\[
P_1 = \left[ \begin{array}{c} \delta \\ 0 \end{array} \right] / r_o, \quad P_2 = \left[ \begin{array}{c} -\delta \\ 0 \end{array} \right] / r_o \quad \text{and} \quad P_3 = \left[ \begin{array}{c} 0 \\ \delta \end{array} \right] / r_o
\]
The system to be solved is:
\[
\begin{align*}
l_1 &= -X \tan \psi + Y + \delta \tan \psi \\
l_2 &= -tan \psi X + Y - \delta \tan \psi \\
l_4 &= X + Y \tan \psi - \delta \tan \psi
\end{align*}
\]
and the solution is:
\[
\begin{align*}
x &= \frac{\delta (2 l_1 - 2 \delta l_2 + 4 \delta l_3 - l_1^2 + l_2^2)}{4 x^2 + l_1^2 - 2 l_1 l_2 + l_2^2} \\
y &= \frac{\delta (l_1^2 - 2 l_1 l_2 + l_1 l_3 + l_2^2 - 2 l_2 l_3 + 2 \delta l_1 l_2 + 2 \delta l_1 l_3 + 2 \delta l_2 l_3)}{4 x^2 + l_1^2 - 2 l_1 l_2 + l_2^2}
\end{align*}
\]

VI. DYNAMIC MODEL OF THE PLATFORM

The global aim of our study is to calculate a feedback control which allows force measurement without displacement of the platform (consign = 0). The figure 9 describes the nature of the problem to be solved. The input vectors are the currents in the coils \( i_1, i_2, i_3 \) and the external efforts \( F_{ext} \) applied to the platform (in the plane \( XOy \)) and considered as perturbations. The output vector is the platform position \( (X, Y, \psi) \).

The state model is going to be established from the differential equations given by the platform dynamic behaviour in the plane \( XOy \):
\[
\ddot{F}_1 + \dddot{F}_2 + F_{\text{ext}}^2 \cdot \dot{\mu} + F_{\text{ext}}^2 \cdot \dot{\mu} = m \ddot{\mu} \quad \text{(12)}
\]
in which \( F_{ext}^2 \) is the external force applied on the floating platform and \( \dddot{F}^2 \) is the viscous friction force between the float and water. In case of small displacement we can write:
\[
\dddot{F} = K_\psi \cdot \dot{\psi} = \begin{bmatrix} K_{\psi x} & 0 \\ 0 & K_{\psi y} \end{bmatrix} \cdot \dot{\psi}
\]
with: \( \Omega \) the instantaneous rotation vector.

A. Evaluation of \( \dddot{F}_1 \)

The force \( \dddot{F}_1 \) applied on the moving magnet \( M_1 \) is given by the following expression:
\[
\dddot{F}_1 = F_{p1}^{\text{mag}} + F_{b3}^{\text{elec}}
\]
where \( F_{p1}^{\text{mag}} \) is the magnetic force applied by \( p_1 \) on \( M_1 \) and \( F_{b3}^{\text{elec}} \) is the electromagnetic force applied by \( b_3 \) on \( M_1 \).

B. Evaluation of \( \dddot{F}_2 \)

The force \( \dddot{F}_2 \) applied on the moving magnet \( M_2 \) is given by the following expression:
\[
\dddot{F}_2 = F_{p2}^{\text{mag}} + F_{b1}^{\text{elec}} + F_{b2}^{\text{elec}}
\]
where \( F_{p2}^{\text{mag}} \) is the magnetic force applied by \( p_2 \) on \( M_2 \), \( F_{b1}^{\text{elec}} \) is the electromagnetic force applied by \( b_1 \) on \( M_2 \) and \( F_{b2}^{\text{elec}} \) is the electromagnetic force applied by \( b_2 \) on \( M_2 \).

The development of the equations (12) allows us to write:
\[
m \begin{bmatrix} \dot{X} \\ \dot{Y} \end{bmatrix} = \begin{bmatrix} -2K_{\psi x} & 0 \\ 0 & -2K_{\psi y} \end{bmatrix} \begin{bmatrix} X \\ Y \end{bmatrix} + \begin{bmatrix} -K_{ix} & 0 \\ 0 & K_{iy} \end{bmatrix} \begin{bmatrix} i_1 \\ i_2 \end{bmatrix} + \begin{bmatrix} -K_{x} & 0 \\ 0 & -K_{y} \end{bmatrix} \begin{bmatrix} x \| \psi \end{bmatrix}
\]
with \( m \) the total platform mass.
In case of circular movement projected on the z-axis, we can write from the dynamic behaviour (14):

$$J_\psi \ddot{\psi} = -K_e \cdot \delta(i_1 \cdot \sin \psi + i_2 \cdot \cos \psi - i_3 \cdot \cos \psi) + 2((K_m^u - K_m^w) \cos \psi - K_m^w) \cdot \sin \psi \cdot \delta^2 - K_{\text{rot}} \dot{\psi} + \zeta_{\text{ext}}$$

For very small $\psi$ we can write $\sin \psi = \psi$, $\cos \psi = 1$ and $i_1 \cdot \sin \psi \approx 0$, thus we have:

$$J_\psi \ddot{\psi} = -K_e \cdot \delta(i_2 - i_3) - 2K_m^w \psi \cdot \delta^2 - K_{\text{rot}} \dot{\psi} + \zeta_{\text{ext}}$$ (18)

(17) and (18) give the linear state model suitable for small displacements:

$$\begin{bmatrix} \dot{x} \\ \dot{y} \\ \dot{\psi} \end{bmatrix} = \begin{bmatrix} -2K_m^x & 0 & 0 \\ 0 & -2K_m^y & 0 \\ 0 & 0 & -2K_{\text{rot}} \end{bmatrix} \begin{bmatrix} x \\ y \\ \psi \end{bmatrix}$$

and the state variable representation is:

$$\begin{bmatrix} \dot{x} \\ \dot{y} \\ \dot{\psi} \end{bmatrix} = \begin{bmatrix} 0 & 0 & 0 \\ 0 & 0 & 0 \\ 0 & 0 & 0 \end{bmatrix} \begin{bmatrix} x \\ y \\ \psi \end{bmatrix}$$

VII. MODEL VALIDATION

Thanks to the dynamic equations, we have build a 2D analytical model programmed in C++ and embedded in Matlab/Simulink. This model allows us to simulate the open loop response of the platform to an external applied force. The figure 10 shows the step responses, for a positive current $i_1 = 0.4 \ A$, of the linear 2D analytical model and the complete 3D analytical model. Instead of using linear equations (1) and (2), the 3D non linear model is based on the calculus of the magnetic inductions generated by the $p_i$ magnets and the $b_i$ coils and applied on the $M_i$ magnets. This allows the determination of the magnetic forces $F_{\text{magn}}$ and the electromagnetic forces $F_{\text{elec}}$ applied to the platform. The complete 3D behavior of the platform is performed by integrating equations (12) and (14) with simulink.

VIII. CONCLUSION

In this paper we have presented a 2D modelling of a six degrees of freedom platform used as the sensing part of a micro and nanoforce sensor based on a floating-magnetic principle. The particular configuration used in order to simplify the differential equations which govern the movement of the platform allowed us to build a 2D linear model of this micro and nanoforce sensor. This linear model and the state variable representation presented in this paper will be essential for the control of our multivariable system in order to achieve force measurement without displacement of the sensing part. In this paper we have also presented the way to calculate the platform position with the use of three laser range sensors mounted in a particular configuration.

REFERENCES